## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Mei Zhu et. al.

Serial No.:

09/966,651

Filed:

September 28, 2001

For:

High Frequency Electrochemical

Deposition

9999

**Group Art Unit:** 

1741

Examiner:

Atty Docket:

56785.US / 01-446

## STATUS REQUEST

Hon. Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

Applicants request a status of the above referenced application. Please mail the status notification to the address stated below.

LSI Logic Corporation 1551 McCarthy Blvd., MS D-106 Milipitas, CA 95035

Date: 31 JAN 03

Respectfully submitted,

Timothy Croll, Ph: [+1] 408-433-7191

Reg. No. 36,771

**FAX RECEIVED** FEB 0 4 2003

**GROUP 1700** 

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